



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2827

In re Application of:

Warren M. Farnworth

Serial No.: 10/074,840

Filed: February 13, 2002

For: STEREOLITHOGRAPHIC METHODS
FOR FABRICATING HERMETIC
SEMICONDUCTOR DEVICE PACKAGES
AND SEMICONDUCTOR DEVICES
INCLUDING
STEREOLITHOGRAPHICALLY
FABRICATED HERMETIC PACKAGES

Examiner: Unknown

Group Art Unit: 2827

Attorney Docket No.: 4212.3US (99-0306.3)

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PRELIMINARY AMENDMENT

Box Non-Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.